

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEE FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Hiroshi TAKANASHI et al.

Serial No. 09/262,077

Filed March 4, 1999



Docket No. 1497/FP/TOK-16-US

Group Art Unit 1752

Examiner S. Lee

NEGATIVE-WORKING PHOTORESISTIVE :  
RESIN COMPOSITION AND  
PHOTORESISTIVE RESIN PLATE USING  
THE SAME

RECEIVED  
CUST. & EXCH.  
U.S. PAT. & T.M. OFFICE  
JUL 13 1999  
REG'D MAIL ROOM

RESPONSE

Assistant Commissioner for Patents,  
Washington, D.C.

Sir:

In response to the Official Action of July 15, 1999, please amend the present application as follows:

IN THE CLAIMS:

Claims 1 to 5, cancel without prejudice to the subject matter thereof, and add the following claims:

--6. A photosensitive resin plate comprising a support having formed thereon directly or via an adhesive layer a photosensitive layer of from 0.45 to 0.8 mm in thickness comprising a negative working photosensitive resin composition consisting essentially of (A) a film-forming polymer, (B) an unsaturated compound having a radical polymerizable ethylenic double bond, (C) a photopolymerization initiator, (D) a thermal polymerization inhibitor, and (E) at least one member selected from compounds represented by following formula (I):

R<sup>1</sup>-X (I)